

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Wen-Jian Lin
Appl. No.	:	10/810,660
Filed	:	March 29, 2004
For	:	STRUCTURE OF A MICRO ELECTRO MECHANICAL SYSTEM AND THE MANUFACTURING METHOD THEREOF
Examiner	:	Jarrett J. Stark
Group Art Unit	:	2823

SUPPLEMENTAL AMENDMENT**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to consideration of the fully responsive reply filed January 17, 2007, the Applicants respectfully request that the Examiner enter the following supplemental amendments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.